

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention

REMOVAL OF MEMS SACRIFICIAL LAYERS USING
SUPERCRITICAL FLUID/CHEMICAL FORMULATIONS

Application Number : 10/782355

Confirmation Number: 4186

First Named Applicant: Michael Korzenski

Attorney Docket Number: 020732-103.686CIP

Art Unit: 2813

Examiner: Tuan H. Nguyen

Search string: (5789505 or 6149828 or 20030073302).pn



US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	5789505	1998-08-04	Wilkinson et al.			
	2	6149828	2000-11-21	Vaartstra			

US Published Applications

Note: Applicant is not required to submit a paper copy of cited US Published Applications

init	Cite.No.	Pub. No.	Date	Applicant	Kind	Class	Subclass
	1	20030073302	2003-04-17	Huibers			

Signature

Examiner Name	Date